

Notice of References Cited		Application/Control No. 09/992,354	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
		Examiner Wen-Tai Lin	Art Unit 2154	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2002/0080798	06-2002	Hariguchi et al.	370/395.31
	B	US-2003/0026268	02-2003	Navas, Julio Cesar	370/400
	C	US-2003/0026246	02-2003	Huang et al.	370/352
	D	US-2003/0014540	01-2003	Sultan et al.	709/240
	E	US-6,704,795	03-2004	Fernando et al.	709/237
	F	US-6,760,777	07-2004	Agarwal et al.	709/238
	G	US-6,850,976	02-2005	Xia, Jay X.	709/224
	H	US-6,574,667	06-2003	Blumenau et al.	709/229
	I	US-6,556,547	04-2003	Srikanth et al.	370/317
	J	US-6,195,703	02-2001	Blumenau et al.	709/238
	K	US-6,584,093	06-2003	Salama et al.	370/351
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
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	Q					
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	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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